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** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

REPUBLIC OF KOREA 2002-75765 12/02/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** SMALL ENTITY **

** 03/12/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 2	TOTAL CLAIMS 9	INDEPENDENT CLAIMS 1
<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature _____ Initials _____				

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TITLE

Method for forming silicon epitaxial layer

 All Fees

FILING FEE	
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